



AF/2815

Docket No.: M4065.0139/P139-A

(PATENT)VED

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#7
1.29.02

In re Patent Application of:
Cem Basceri

Application No.: 09/633,132

Group Art Unit: 2815

Filed: August 4, 2000

Examiner: E. Lee

For: METHOD FOR IMPROVING THE
SIDEWALL STOICHIOMETRY OF THIN
FILM CAPACITORS

REQUEST FOR RECONSIDERATION

Box AF
Commissioner for Patents
Washington, DC 20231

Dear Sir:

In response to the Office Action dated October 10, 2001, finally rejecting claims 39, 41-48, 50-56 and 74-83, please reconsider the above-identified U.S. patent application in light of the following remarks: